IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jeng-Yang Pan

Group Art Unit: 2813

Serial No.: 10/ 013,089

Examiner: Jennifer M. Dolan

Filed:

Dec. 7, 2001

In Response to Office Action

Dated: March 4, 2003

For:

Semiconductor Wafer Tray Positioning

Attorney Docket No.: 67,200-627

## Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Date: <u>March 25, 2003</u>

## RESPONSE TO OFFICE ACTION

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In response to an Office Action mailed March 4, 2003 of a restriction requirement imposed by the Examiner, the Applicants hereby elect with traverse the prosecution of Group I, apparatus claims, (claims 1-17).

> Respectfully submitted, TECHNOLOGY CHNTER 2806 Tung & Associates Randy W. Tung Req. No. 31,311 Telephone: (248) 540-4040